




Exhibitor Introduction

※ Please write it in English.

Name of Company	FINE SEMITECH CORP.	Company Logo
President	Kyung Byn, Chang	
Address	15-23, Dongtansandan 6-gil, Hwaseong-si, Gyeonggi-do, Republic of Korea	
Website	www.fstc.co.kr	
E-mail	hr@fstc.co.kr	
Tel.	031-371-2400	
Exhibitor Introduction	Founded in 1987, FST has grown into a leading provider of semiconductor process temperature control systems and pellicle technologies. Through continuous innovation and quality excellence, we deliver reliable solutions that ensure stability and efficiency across advanced semiconductor manufacturing environments.	
Exhibit Description	FST showcases its core expertise in semiconductor process control, focusing on advanced chiller and pellicle technologies that ensure precision and stability in next-generation semiconductor manufacturing. We demonstrate how continuous R&D and engineering innovation enable us to deliver reliable solutions that enhance process performance and manufacturing quality.	
Exhibit Product	<ul style="list-style-type: none">• DUV Pellicle – High-transmittance protective film ensuring photomask cleanliness and yield stability.• EUV Pellicle – Ultra-thin, high-durability membrane with >90% EUV transmittance.• Chiller System – Precision cooling equipment enabling thermal stability for semiconductor and display processes.• EUV Infrastructure Tools (EPMD(EUV Pellicle Mounter & Demounter))<ul style="list-style-type: none">– Automated pellicle mounter/demounter system designed for safe handling and accurate attachment of ultra-thin EUV pellicles, minimizing defects and improving process reliability.	